



PATENT  
Atty Docket No. KLAC0012

*Amdt  
Shawis  
7/26/02*

I CERTIFY THAT ON JUNE 28, 2002, WHICH IS THE DATE I AM SIGNING THIS CERTIFICATE, THIS CORRESPONDENCE AND IDENTIFIED ENCLOSURES ARE BEING DEPOSITED IN THE UNITED STATES POSTAL SERVICE, POSTAGE PAID FIRST CLASS, IN AN ENVELOPE ADDRESSED TO: COMMISSIONER OF PATENTS AND TRADEMARKS, WASHINGTON, D.C. 20231.

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STEVEN W. SMYRSKI

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Group Art Unit: 2878

CHRISTOPHER FAIRLEY, ET AL.

Examiner: Eric J. Spears

Title: CONFOCAL WAFER INSPECTION  
METHOD AND APPARATUS

Serial No.: 09/533,203

Filed: MARCH 23, 2000

**RESPONSE TO OFFICE ACTION**

Hon. Commissioner of Patents and Trademarks  
Washington, D.C. 20231

Sir:

In response to the Office Action dated February 28, 2002, please consider the following remarks in connection with the above-identified patent application.

07/11/2002 AMAB11 00000077 09533203

01 FC:103  
02 FC:102

306.00 OP  
252.00 OP